

Search Notes

Application No.

10/620,799

Examiner

Emily Y Chan

Applicant(s)

ARNOUX ET AL.

Art Unit

2829

SEARCHED

Class	Subclass	Date	Examiner
324	141,74	6/28/2004	EC
324	551	6/28/2004	EC
345	173	3/28/2004	EC
702	127	3/28/2004	EC
324	141, 158.	3/30/2005	EC
345	173	3/30/03	EC
above	updated	3/30/2005	EC

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
same	as above	3/30/2005	EC

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST and Japan IPDL database searched	6/28/2004	EC
Inventorship and EAST for all the databases searched	3/30/2005	EC